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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

INOUE et al.

Serial No.: 09/228,148

Filed: January 11, 1999

For: SEMICONDUCTOR DEVICE INCLUDING AN INSULATING  
FILM ON A CONDUCTIVE LAYER AND MANUFACTURING  
METHOD THEREOF



RECEIVED

MAY 27 1999

TECHNOLOGY CENTER 2800  
Examiner: Not yet assigned

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT TO 37 CFR 1.97(b)**

Assistant Commissioner for Patents  
Washington, D.C. 20231

May 24, 1999


Sir:

This Information Disclosure Statement is being filed in order to comply with Applicant's duty of disclosure under 37 CFR 1.56. The documents listed on the Form PTO-1449 were references cited in the related application Serial Nos. 08/877,931, 08/997,049 and 08/949,283.

The Commissioner is authorized to charge our Deposit Account No. 01-2340 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully submitted,

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